

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	09/820,449	BESHENAR ET AL.	
	Examiner	Art Unit	Page 1 of 1
	Clemence Han	2665	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,697,366.	02-2004	Kim, San-Hong	370/392
	B	US-6,021,132	02-2000	Muller et al.	370/412
	C	US-5,426,424	06-1995	Vanden Heuvel et al.	340/7.52
	D	US-6,088,777	07-2000	Sorber, Gordon P.	711/171
	E	US-5,784,698	07-1998	Brady et al.	711/171
	F	US-6,604,147	08-2003	Woo, Thomas Y	709/240
	G	US-5,475,383	12-1995	Ohta et al.	370/382
	H	US-6,421,769	07-2002	Teitenberg et al.	711/170
	I	US-5,970,069	10-1999	Kumar et al.	370/402
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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